INDEC

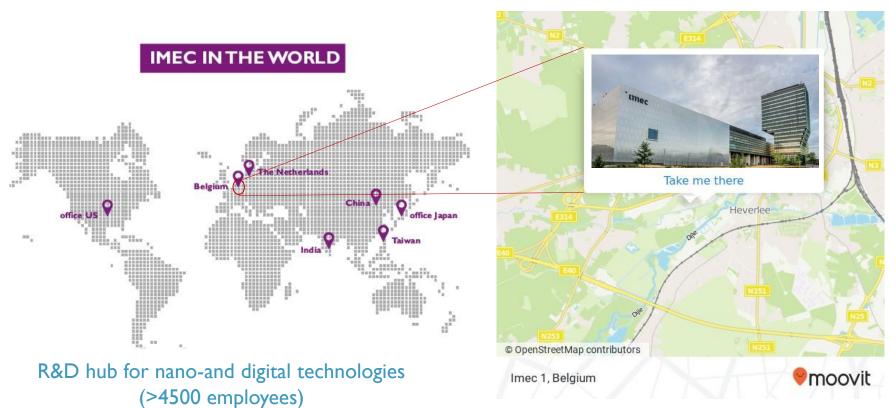
First-principles calculations as a backbone for the development of semiconductor technologies

10th Abinit International Developer Workshop 2021

Benoit Van Troeye, Geoffrey Pourtois

What is IMEC ?

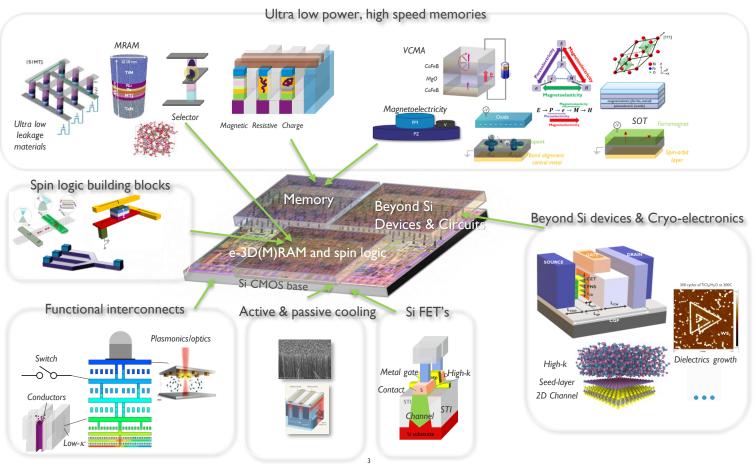
Site at Leuven



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2030 + ?



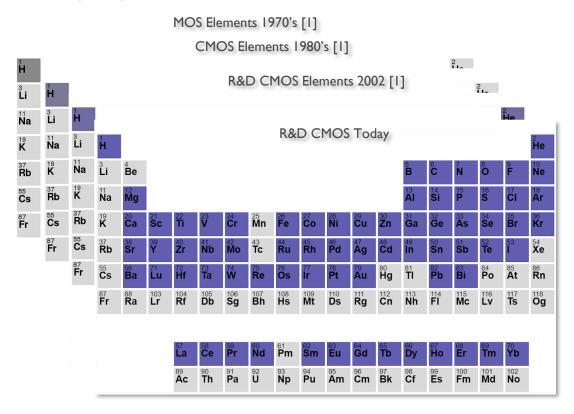
Core CMOS & Memory expertise centers

EXPERTISE CENTERS	LITHO	LOGIC	MEMORY	3DOIO	Other	
MATERIALS AND PROCESSES						
Metrology for PROCESS CONTROL						
PHYSICAL CHARACTERISATION						
MODELING & RELIABILITY						

ATOMISTIC MODELING ACTIVITIES WITHIN IMEC Optical-Proximity Correction Compact & circuit modeling, TCAD, mechanical, thermal and electrical reliabilities, physical, exploratory devices, atomistic modeling,... Optical, thermal, mechanical, reliability,... Acoustics, optical,TCAD, fluidics,...

New materials = source of inspiration

but also of perspiration, ...



Large number of possible combinations

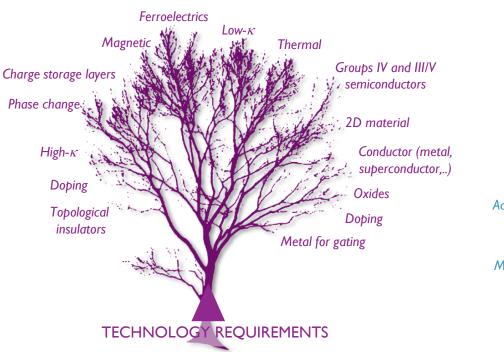
One material = different functions & phases

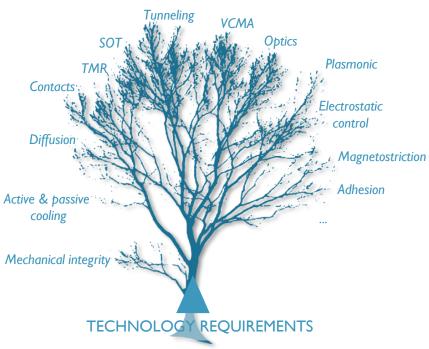
Selection process ?

MATERIAL AND TECHNOLOGY

MATERIAL TREE

INTERFACE TREE

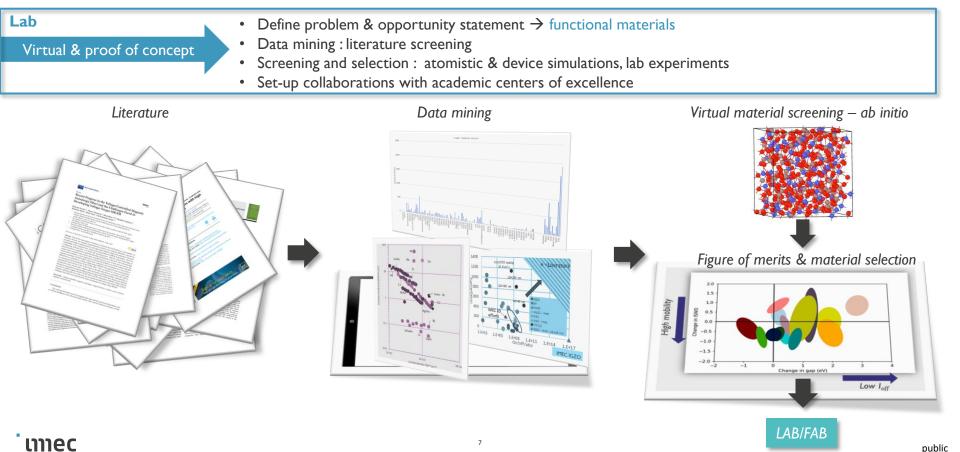




Challenges:

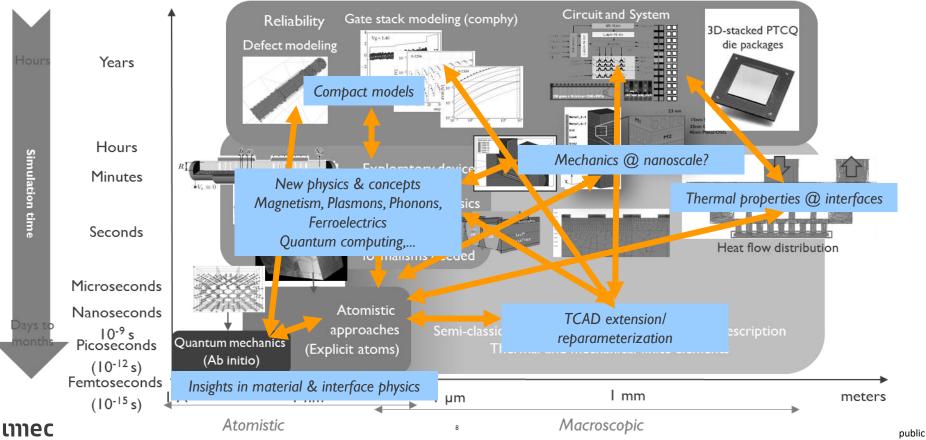
- Abundancy of reports and of possible solutions
- Confusing literature no clear benchmarks, results are process and methodology dependent,...
- No clear winner(s)

Material journey: from concept to 300mm angstrom Material pilot line



Modeling playground

Building bridges between modeling approaches

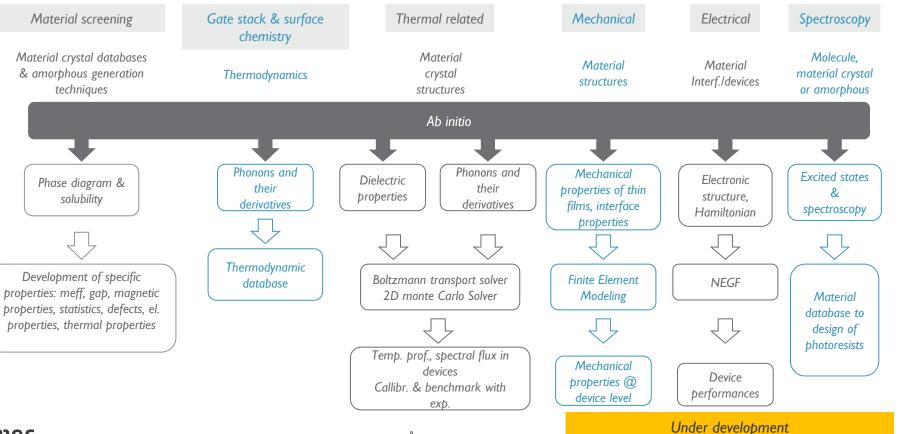


Material screening & multiscale effort

Ad-hoc solution: imec in house workflows

Ab initio Quantum mechanics

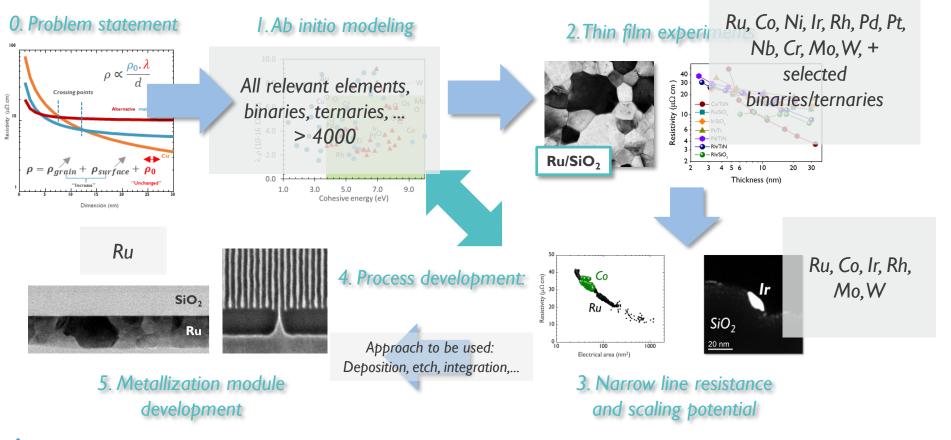
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Material screening

Selection of metals for interconnect



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Multiscale modeling

Boltzmann transport equation – Monte Carlo Bulk thermal conductivities Thermal transport in materials Cu Ru First-principle 1.0 1.0 DFT calculations 0.8 0.8 0.0 kcum/Kbulk 0.0 kcnm/K^{bulk} **Electron and phonon** Electro properties phonon phonon 0.2 0.2 electron electron Material thermal 0.0 0.0 BTE simulation for Heat 10² 100 101 properties 10⁰ 10¹ 10² MFP[nm] MFP[nm] heat carriers Thin films thermal conductivities emperature distribution scattering Thermal-aware [W/(K.m) Cu **EM** modeling 12FEM for large $K_{\rm ph})$ [%] scales Thermal conductivity 10Ru Crossover Electron and phonon properties are calculated from DFT to $K_{\rm ph}/(K_{\rm el}$ obtain thermal conductivity.

Ex: Atomistic calculations - material thermal properties

- Thermal conductivity is modeled in thin film metals using scattering parameters calibrated from elect. measurements.
- Crossover of Cu thermal conductivity with annealed Ru < 5nm.

30 35

25

0 510 15 20 25

Film thickness [nm]

30

5

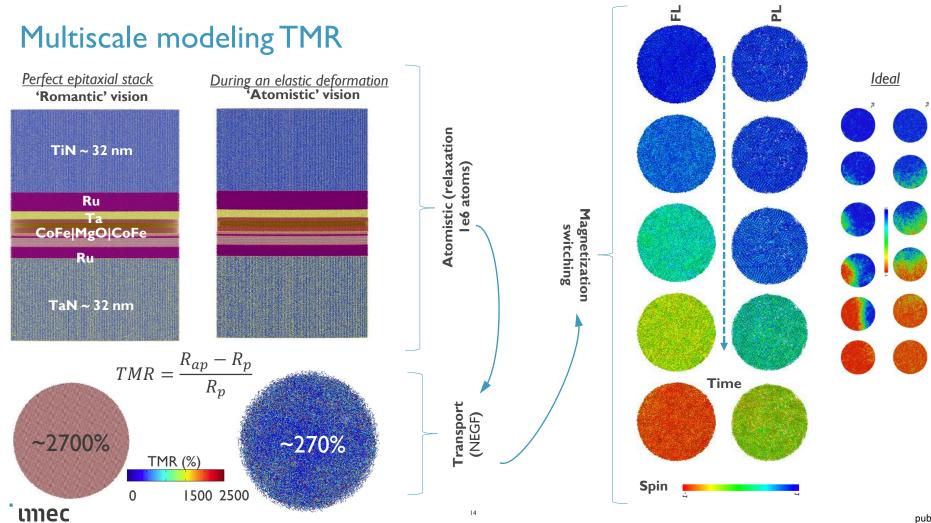
10 1520

Film thickness [nm]

0

TaN/Cu/TaN

Ru/SiO₂(dep) -Ru/SiO₂(ann) TaN/Ru/TaN



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